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CONFIRMATION NO. 4558

<b>SERIAL NUMBER</b> 10/537,529	<b>FILING OR 371(c) DATE</b> 06/03/2005 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 4887/PCT
<b>APPLICANTS</b> Makoto Otsuki, Itami-shi, JAPAN; Masayuki Nishikawa, Itami-shi, JAPAN; Yasuyuki Matsui, Itami-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP04/08108 06/10/2004				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-176746 06/20/2003				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 5	<b>TOTAL CLAIMS</b> 40
Verified and Acknowledged Examiner's Signature _____ Initials _____		<b>INDEPENDENT CLAIMS</b> 2		
<b>ADDRESS</b> 21553				
<b>TITLE</b> Method of producing semiconductor single crystal wafer and laser processing device used therefor				
<b>FILING FEE RECEIVED</b> 1900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	